INTERNATIONAL SEARCH REPORT

international Application No FR2004/001634

A. CLASSIFICATION OF SUBJECT MATTER IPC 7 C30B1/02 C30B29/06

C30B25/02

H01L21/00

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B82B3/00

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

IPC 7

C30B H01L B82B

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, PAJ, INSPEC, WPI Data

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category °	Citation of document, with indication, where appropriate, or	the relevant passages	Relevant to claim No.
A	US 5 827 773 A (VOUTSAS TOLIS 27 October 1998 (1998-10-27) the whole document	1	
A	KUNII ET AL.: "Solid Phase I epitaxy of chemical vapor dep amorphous silicon by furnace JOURNAL OF APPLIED PHYSICS, vol. 54, no. 5, May 1983 (198 2847-2849, XP002274241 NEW YORK US cited in the application the whole document	osited annealing"	1
X Furth	er documents are listed in the continuation of box C.	Patent family members are listed i	n annex.
*A' documer conside "E" earlier di filing de "L' documer which is citation "O" documer other m "P" documer	nt which may throw doubts on priority claim(s) or s cited to establish the publication date of another or other special reason (as specified) nt referring to an oral disclosure, use, exhibition or	"T" later document published after the inte or priority date and not in conflict with cited to understand the principle or the invention "X" document of particular relevance; the c cannot be considered novel or cannot involve an inventive step when the do "Y" document of particular relevance; the c cannot be considered to involve an involve an involve and in the art. "&" document member of the same patent.	the application but ony underlying the laimed Invention be considered to current is taken alone laimed invention ventive step when the re other such docu- is to a person skilled
Date of the a	clual completion of the international search	Date of mailing of the international sear	
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05/11/2004

Authorized officer

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27 October 2004

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	tion) DOCUMENTS CONSIDERED TO BE RELEVANT Citation of document, with indication, where appropriate, of the relevant passages		Relevant to claim No.	
Category °	Citation of document, with indication, where appropriate, of the relevant passages		nelevani io Gaini ioo,	
A	AUDIER ET AL.: "Crystallographic orientations of catalytic particles in filamentous carbon; case of simple conical particles" JOURNAL OF CRYSTAL GROWTH., vol. 55, 1981, pages 549-556, XP002274242 NORTH-HOLLAND PUBLISHING CO. AMSTERDAM., NL ISSN: 0022-0248 cited in the application		***	
A .	MEYYAPAN ET AL.: "Carbon nanotube growth by PECVD: a review" PLASMA SOURCES AND TECHNOLOGY, vol. 12, 2003, pages 205-216, XP002274243 UK cited in the application			
A	FR 2 832 995 A (THALES) 6 June 2003 (2003-06-06)		·	
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INTERNATIONAL SEARCH REPORT

Information on patent family members

International Application No FR2004/001634

	ent document in search report		Publication date		Patent family member(s)	Publication date
US	5827773	A	27-10-1998	JP JP US US	3558200 B2 10291897 A 5959314 A 6329270 B1 6169013 B1	25-08-2004 04-11-1998 28-09-1999 11-12-2001 02-01-2001
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.Form PCT/ISA/210 (patent family annex) (January 2004)